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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/651,277
Filing Date: 08/28/2003
Applicant: Yoshifumi Okabe, et al.
Group Art Unit: 2811
Examiner: Steven Loke
Title: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING SAME
Attorney Docket: 4041J-000499/DVE

Mail Stop Amendment
Director of The United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed September 24, 2004, Paper No./Mail Date 20040919, please amend and reconsider the above referenced patent application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 5 of this paper.